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	Filing Date		2003-09-29	
	First Named Inventor	Shuhei Yamada		
	Art Unit	1792		
	Examiner Name	George A. Goudreau		
Attorney Docket Number		O11.2-11335-US01		

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1	"Superprecision Wafer Surface Control Technology", Science Forum Inc., the first edition, page 215	<input checked="" type="checkbox"/>
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